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	Application No.	Applicant(s)	
Matica of Allowahility	10/642,268	ISHII ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Parviz Hassanzadeh	1763	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this applied or other appropriate communication IGHTS. This application is subject to	pplication. If not include n will be mailed in due	ed course. THIS
1. This communication is responsive to 6/14/04.			
2. The allowed claim(s) is/are <u>1-4</u> .			
3. The drawings filed on <u>02 December 2003 and 18 August 20</u>	003 are accepted by the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application No. <u>09</u>		tion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply ENT of this application.	complying with the rec	quirements
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) hereto or 2) to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	.84(c)) should be written on the drawin he header according to 37 CFR 1.121(ngs in the front (not the	back) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT F	sit of BIOLOGICAL MATERIAL r FOR THE DEPOSIT OF BIOLOGIC	nust be submitted. N AL MATERIAL.	Note the
Attachment(s) 1. Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P		O-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0-Paper No./Mail Date	8), 7. ⊠ Examiner's Amendr	Paper No./Mail Date 7. ⊠ Examiner's Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit	8. X Examiner's Stateme	ent of Reasons for Allo	wance
of Biological Material	9.		
		Parviz Hassanzade Primary Examiner Art Unit: 1763	∍h

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EXAMINER'S AMENDMENT

DETAILED ACTION

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Dustin Johnson (Reg. No. 47684) on 7/20/04.

The application has been amended as follows:

IN THE CLAIMS:

Have canceled non-elected claims 5-12.

Allowable Subject Matter

Claims 1-4 are allowed.

The following is an examiner's statement of reasons for allowance: a plasma processing system including a flat antenna and a radio-frequency wave transmitting window propagating plasma-producing radios-frequency waves into a vacuum processing vessel;

wherein an electromagnetic wave absorber disposed between the radio-frequency wave transmitting window and the antenna so as to surround a region between a surface of the radio-frequency wave transmitting window on a side of a vacuum atmosphere in the vacuum vessel.

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EX. Amdt.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Ohmi et al (WO098/33362), Ohmi et al (US Patent No. 6,357,385 B1), and Goto et al (US Patent No. 6,347,602 B2) teach microwave plasma processing system wherein microwaves is propagated via a flat antenna through a window into a processing chamber.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Parviz Hassanzadeh whose telephone number is (571)272-1435. The examiner can normally be reached on Tuesday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (571)272-1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

P. Hassanzadeh Parviz Hassanzadeh Primary Examiner Art Unit 1763

July 23, 2004